

Final Presentation AEPD2: IOM Activities

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Introduction

Outline

- Introduction
 - Tasks
- Diagnostic tools
 - Design
 - Performance characterization
- Results of test campaigns
 - 🖊 RIT-μX
 - SPT-100ML
- Summary





Tasks

- Design, manufacturing, performance characterization of diagnostic tool
 - Telemicroscope
 - Triangular laser head
 - Pyrometer
 - Thermocamera
 - Retarding potential analyzer
 - Faraday probe
- Design, manufacturing, performance characterization of diagnostic system
- Perform and analyze test campaigns
 - Thrusters: RIT-µX (ArianeGroup), SPT-100ML (ICARE)
 - Facilities: Jumbo (JLU), MVTF

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Telemicroscope: Design









- Housing with graphite front plate and sapphire window
- 4 LEDs for object illumination
- Dimension 60 x 70 x 214 mm³
- Øperational test in air and in vacuum was performed successfully
- NOT specified for in-vacuum operation:
 Electronic parts had to be replaced
- Status: Ready for test campaigns

Telemicroscope



Telemicroscope: Performance characterization

Microscope image (lens 12.5x)



10 µm / 15 µm

Microscope images (lens 3.5x)



50 µm / 50 µm



20 µm / 20 µm



100 µm / 100 µm



- Calibration with test structures
 - Laser scribed line structures: characterization of lateral resolution
 - Graticule structure: image size and quality



Telemicroscope



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Telemicroscope: Performance characterization



- Comparison of calculated performance data with experimental results (in dependence on extension tube length):
 - Working distance
 - Field of view
 - Lateral resolution
- Very good agreement
- Focal length: 50 mm
- Extension tube length: 40 mm
- Working distance: 112.5 mm
- Field of view: 8.75 x 6.56 mm²
- Lateral resolution: < 10 μm</p>



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Laser head: Design







- Housing with graphite front plate and sapphire window
- Dimensions: 95 x 47 x 127 mm³
- Øperational test in air and in vacuum was performed successfully
- NOT specified for in-vacuum operation:
 - Electronic parts had to be replaced
- Status: Ready for test campaigns



Laser head: Performance characterization

- Calibration using a high-precision linear table (positioning accuracy 10 µm)
- Relative distance measurement (with respect to reference plane)
- // (Relative) distance accuracy: +/- 20 μm



TLH

Reference

plane

High-precision linear table









Pyrometer: Design









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- Steel housing with sapphire window
- Dimension: Size 25 x 30 x 47 mm³

(compared to former AEPD-1: 300 mm / Ø 200 mm cylinder)

- Operational test in air and in vacuum was performed successfully
- NOT specified for in-vacuum operation:

Electronic parts had to be removed or replaced

Status: Ready for test campaigns

Pyrometer

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Pyrometer: Performance characterization

/ Thermocalibrator Optris BR 400: $T_{max} = 400^{\circ}C$; accuracy < 2°C

Difference between set and measured temperature

(w/o sapphire window): $< 2^{\circ}C$

Window effects need to be corrected

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Thermocamera: Design









- Housing with graphite front plate and ZnS window
- Dimension: 56 x 60 x 143 mm³
 (AEPD-1: diameter 150 mm)
- Øperational test in air and in vacuum was performed successfully
- NOT specified for in-vacuum operation:
 Electronic parts had to be replaced
- Status: Ready for test campaigns

Thermocamera

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Thermocamera: Performance characterization

/ Thermocalibrator Optris BR 400: $T_{max} = 400^{\circ}C$; accuracy < 2°C

Difference between set and measured temperature

(w/o ZnS window): $< 10^{\circ}$ C

Window effects need to be corrected

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RPA: Design





Graphite grid: 149 holes, hole diameter 0.4 mm, hexagonally arranged

- Dimension: 38 x 39 x 16 mm³
- Performance test of electronics was performed successfully
- Status: Ready for test campaigns







RPA design is simulated by using IBSIMU software

- RPA was tested with ion beam source (IOM)
- Voltage measurement done using a calibrated instrument
- Comparison with ESMS in progress



Faraday probe: Design





- Dimension: length 102 / 132 mm, diameter 6 / 24 mm
- Performance test of electronics was performed successfully
- Status: Ready for test campaigns







Preliminary characterization done with RIT-22

- Current measurement calibrated with constant current source
- Current measurement employs an accuracy resistance
- Probe area is measured with calibrated vernier caliper



Vacuum feedthroughs





- USB connectors: Telemicroscope, pyrometer, thermocamera
- BNC connectors: RPA, Faraday cup
- Customized Lemo connector: TLH



- All feedthroughs (including connectors and cables) manufactured and assembled
- Operational tests in air and in vacuum were performed successfully
- Status: Ready for test campaigns



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System setup with RIT-µX







Diagnostic

arm 1

(fixed)





Diagnostic arm 2 (movable)

Positioning system



System



System setup (Diagnostic arms)

Thermoprobe (CAU)

RPA

ExB (Aerospazio)

Diagnostic arm 1 (fixed)





Faraday probe

TLH/Pyrometer

Thermocamera Telemicroscope Diagnostic arm 2 (y-axis)





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List of performed measurements

	RIT-µX	SPT100-ML
Faraday probe	\checkmark	\checkmark
Retarding potential analyzer (RPA)	\checkmark	\checkmark
Pyrometer (Pyr)	Out of range	\checkmark
Thermocamera (ThC)	\checkmark	\checkmark
Telemicroscope (TMS)	\checkmark	\checkmark
Triangular laser head (TLH)	\checkmark	\checkmark

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RIT-µX: Operation points

Operation Point 1

- Beam voltage: 1050 V
- Beam current: 4 mA
- Accelerator voltage: -200 V
- Nominal thrust: 210 μN

Operation Point 2

- Beam voltage: 1700 V
 Beam current: 8 mA
- Accelerator voltage: -250 V
- ✓ Nominal thrust: 540 μN

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RIT-µX: Faraday probe

Operation Point 1

- Jumbo (JLU Gießen)
- Operation Point 2





// $j_{max} = 0.18 \text{ mA/cm}^2 \pm 0.02 \text{ mA/cm}^2
// FWHM = 48 \text{ mm} \pm 2 \text{ mm}$

- $j_{max} = 0.52 \text{ mA/cm}^2 \pm 0.04 \text{ mA/cm}^2$
 - FWHM = 41 mm \pm 2 mm





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RIT-µX: Faraday probe

Operation Point 1



Operation Point 2

Scans at two distances: 120 mm / 150 mm

- Slightly higher current density in Jumbo (Gie) than in MVTF (Rap)
- FWHM very similar

RIT-µX: RPA

Operation Point 1

Jumbo (JLU Gießen)

Operation Point 2



RIT-µX: RPA

Jumbo (JLU Gießen)

Operation Point 1

MVTF (Aerospazio)



Operation Point 1







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RIT-µX: Thermocamera











RIT-µX: Telemicroscope

Jumbo (JLU Gießen)



MVTF (Aerospazio)

Center hole diameter: (1.27 ± 0.02) mm



Cycle 1



RIT-µX: TLH

Jumbo (JLU Gießen)









SPT100-ML: Operation points

Operation Point 1

- Anode voltage: 300 V
- Anodic mass flow: 3 mg/s
- Cathode mass flow: 0.5 mg/s
- Current: 2.5 A

Operation Point 2

- Anode voltage: 300 V
 Anodic mass flow: 5 mg/s
 Cathode mass flow: 0.5mg/s
- Current: 4.5 A

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SPT100-ML: Faraday probe

Jumbo (JLU Gießen)



Horizontal line scan across center of thruster

Asymmetric beam profile, higher current density at operation point 2







SPT100-ML: Faraday probe

Jumbo (JLU Gießen)

MVTF (Aerospazio)



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SPT100-ML: RPA



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Jumbo (JLU Gießen)

SPT100-ML: RPA

MVTF (Aerospazio)

Operation point 2

Jumbo (JLU Gießen)



= E_{max} = 269 eV ± 2 eV



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SPT100-ML: Pyrometer

Operation Point 1





Good agreement between Jumbo (Gie) and MVTF (Rap)

Thruster temperature higher in operation mode 2 than in operation point 1



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SPT100-ML: Thermocamera

Operation Point 1, right channel









- Good agreement between Jumbo (Giessen) und MVTF (Rapolano)
- Differences in linescans are not artifacts (see images)



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SPT100-ML: Thermocamera

Operation Point 2, right channel







Good agreement between Jumbo (Giessen) und MVTF (Rapolano)

Differences in linescans are not artifacts (see images)

SPT100-ML: Telemicroscope

Inner ceramic wall



- Jumbo (JLU Gießen)
- Outer ceramic wall



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Top edge of channel walls already eroded (axial erosion ~ 4.5 mm ± 1.0 mm)



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SPT100-ML: TLH

Jumbo (JLU Gießen)





Publications

Summary

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Summary

Summary

- AEPD2 system design, manufactured and tested
- Diagnostic tools developed and performance evaluated
 - Optical measurements: telemicroscope, triangular laser head
 - Temperature measurements: pyrometer, thermocamera
 - Particle beam measurements: retarding potential analyzer, Faraday probe, active thermal probe
- System operated well at all test campaigns
 - Jumbo (JLU Gießen): RIT-µX & SPT-100ML
 - MVTF (Aerospazio): RIT-µX & SPT-100ML
- In general very good reproducibility of results within the same facility
- Comparison of results between different facilities shows "facility effects", for example from background temperature and pressure
- Deeper understanding the facility effects requires further studies
- For better quantification, window effects (Pyr, ThC) need to addressed in more detail







Appendix



Appendix

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Telemicroscope

Telemicroscope: Sources of uncertainty

- Vacuum (lack of convection)
 - Can affect operation of electronics (maximum temperature 85° C), no problems encountered in test campaign
- Rise of temperature due to interaction with energetic particle beam
 - Thermal expansion of mechanical parts, e.g. extension tube length, minimal effect on performance and can be examined by calculation
- Contamination by sputtered material:
 - Can affect image quality, protect window if not in operation
- Setup:
 - Window in image path: no effect detected



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Laser head: Sources of uncertainty

- Vacuum (lack of convection)
 - Can affect operation of electronics (maximum temperature 85° C), no problems encountered in test campaign
- Rise of temperature due to interaction with energetic particle beam
 - Thermal expansion of mechanical parts, e.g. window, can be examined by calculation (expected to be negligible)
- Contamination by sputtered material:
 - Can affect signal intensity,
 - no problems encountered in test campaign
- Setup:
 - Window effect: relative distance changes are measured accurately



Pyrometer

Pyrometer: Sources of uncertainty

- Vacuum (lack of convection)
 - Can affect operation of electronics (maximum temperature 85° C), no problems encountered in test campaign
- Rise of temperature due to interaction with energetic particle beam
 - Thermal expansion of mechanical parts expected to be negligible
 - Heated window can affect results: to be examined by calculation
- Contamination or erosion by sputtered material:
 - Can affect window and, hence, signal intensity: needs to be tested in additional test campaign, can be examined by calculation and experiment
- Test object:
 - Emissivity error: to be examined by calculation and experiment
- Setup:
 - Window effect: experiment and/or calculation





Thermocamera: Sources of uncertainty

Vacuum (lack of convection)

Thermocamera

- Can affect operation of electronics (maximum temperature 85° C), chip temperature can be read out from software
- Rise of temperature due to interaction with energetic particle beam
 - Thermal expansion of mechanical parts expected to be negligible
 - Heated window can effect results: to be examined by calculation
- Contamination by sputtered material:
 - Can affect window and, hence, signal intensity: needs to be tested in additional test campaign, can be examined by calculation and experiment
- Test object:
 - Emissivity error: to be examined by calculation and experiment
- Setup:
 - Window effect: experiment and/or calculation



RPA: Sources of uncertainty

- Vacuum (lack of convection)
 - No effect, electronics outside vacuum
- Rise of temperature due to interaction with energetic particle beam
 - Thermal expansion of grids: can be examined by calculation, influence on measured ion energy expected to be small
- Contamination by sputtered material:
 - No effect expected
- Electronics (measurements and/or manufacturer's data):
 - High voltage power supply
 - Isolation amplifier
 - Measurement resistor
 - Data acquisition module

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Faraday Probe

Faraday probe: Sources of uncertainty

- Vacuum (lack of convection)
 - No effect, electronics outside vacuum
- Rise of temperature due to interaction with energetic particle beam
 - Thermal expansion of measurement area:
 - can be examined by calculation, expected to be negligible
- Contamination by sputtered material:
 - No effect expected
- Electronics (measurements and/or manufacturer's data) and setup:
 - Measurement area
 - Measuring resistor
 - Data acquisition card
 - Cable and feedthrough



